



IFW

PATENT  
8070-1003

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

In re application of:

Tatsuya SUZUKI et al.

Appl. No.: 10/685,571

Filed: October 16, 2003

Conf.: 7159

Group: 2812

Examiner: W.Lindsay, Jr.

METHOD FOR MANUFACTURING SEMICONDUCTOR  
DEVICE AND SEMICONDUCTOR DEVICE

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

November 30, 2004

Sir:

In response to the Office Action mailed November 1, 2004, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 11 of this paper.